



IFW

PATENT
Attorney Docket No. 4632-64

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Kyoichi Iwata) Group Art Unit: 2125
)
Application No.: 10/525,741) Examiner: Michael D. Masinick
)
Filed: February 28, 2005)
)
For: Dent Distribution Diagram Drawing) Confirmation No.: 8293
Method and System in Shotblasting, and)
Processing Conditions Setting Method)
and Shotblasting Device)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REPLY TO OFFICE ACTION

In reply to the Office Action mailed September 1, 2006, please amend the
above-identified application as follows:

Amendments to the Specification are included in this paper.

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.